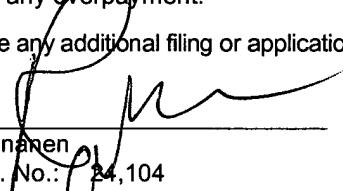


2823

<b>AMENDMENT TRANSMITTAL LETTER</b>				Docket No. SON-2192
Application No. 09/939,773 Conf. # 3157	Filing Date August 28, 2001	Examiner W.D. Coleman	Art Unit 2923	
Applicant(s): Koji KIKUCHI				
Invention: MANUFACTURING METHOD OF A PHASE-SHIFT MASK, METHOD OF FORMING A RESIST PATTERN AND MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE				
<b>TO THE COMMISSIONER FOR PATENTS</b>				
Transmitted herewith is an amendment in the above-identified application.				
The fee has been calculated and is transmitted as shown below.				
<b>CLAIMS AS AMENDED</b>				
Total Claims	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate
10	- 20 =		x	0.00
Independent Claims	2	- 3 =	x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>				
Other fee (please specify):				
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b> 0.00				
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity				
<input type="checkbox"/> No additional fee is required for this amendment.				
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.				
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.				
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.				
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 18-0013 as described below. A duplicate copy of this sheet is enclosed.				
<input checked="" type="checkbox"/> Credit any overpayment.				
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.				
Dated: September 9, 2003				
 Ronald P. Kananen Attorney Reg. No.: 24,104				
RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750				

RECEIVED  
TECHNICAL CENTER 2000  
SEP 1 2003



## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koji KIKUCHI

Application No. 09/939,773

Filed: August 28, 2001

Examiner: William D. Coleman

Art Unit: 2823

Confirmation No. 3157

For: MANUFACTURING METHOD OF A PHASE-SHIFT MASK, METHOD OF  
FORMING A RESIST PATTERN AND MANUFACTURING METHOD OF A  
SEMICONDUCTOR DEVICE

RECEIVED  
TECHNICAL CENTER 2800  
SEP 11 2003

RESPONSE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following is presented in response to the non-final Office Action dated June 11, 2003 (Paper No. 9):